



IFW

Attorney Docket No. MXIC 1532-1

CERTIFICATE OF MAILING

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Paula Faulk Hurley
Paula Faulk Hurley

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Chih Yuan Huang Application No.: 10/621,120 Confirmation No.: 1938 Filed: July 16, 2003 Title: Method of Forming Silicon Film with Changing Grain Size by Thermal Process	Attorney Docket No.: MXIC 1532-1 Examiner: Andy Huynh Group: 2818 Customer No. 22470
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RESPONSE A

Mail Stop Amendment
Commissioner for Patents
Post Office Box 1450
Alexandria, Virginia 22313-1450

Sir:

This RESPONSE A is in reply to the Office action mailed September 29, 2004. No fee is due.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.